Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S31	1347	(141/98).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/04/26 16:58
S32	258	S31 @pd>"20010101"	US-PGPUB; USPAT; USOCR	AND	ON	2005/04/26 17:35
S39	0	(414/217).ccls. @pd<"20030224" EFEM FOUP nozzle	US-PGPUB; USPAT; USOCR	AND .	ON	2005/04/26 18:45
S44	1	S33 EFEM FOUP gas near nozzle inert	US-PGPUB; USPAT; USOCR	AND	ON	2005/04/26 18:37
S71	2	(34/406).ccls. @pd<"20030224" gas near nozzle	US-PGPUB; USPAT; USOCR	AND	ON	2005/04/27 09:40
S96	480	("118").clas. @pd<"20020224" gas near (nozzle or inlet) inert near gas (wafer or semiconductor)	US-PGPUB; USPAT; USOCR	AND	ON .	2005/04/27 13:06
S10 1	37	(141/98).ccls. @pd<"20030224" gas near (inlet or nozzle)	US-PGPUB; USPAT; USOCR	AND	ON	2005/04/27 13:14